

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Takashi WATANABE et al.**

Art Unit: **2818**

Application Number: **10/823,729**

Examiner: **David Vu**

Filed: **April 14, 2004**

Confirmation Number: **5344**

For: **SEMICONDUCTOR DEVICE FABRICATION METHOD**

Attorney Docket Number: **042341**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. § 1.312

Mail Stop: Issue Fee

April 14, 2011

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Notice of Allowance dated January 25, 2011, Applicant herein amends the above-identified application as follows and submits the following remarks.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.